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LIST OF PATENTS AND PUBLICATIONS FOR			NS FOR	FILING DATE	GROUP A	GROUP ART UNIT	
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(use several sheets if necessary) APPLICANT(			S): Roland Henge	erer	CONFIRM	CONFIRMATION NO. 2842	
REFERENCE	DESIGNATION	U.S.	PATENT DOCU	MENTS	_		
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## FOREIGN PATENT DOCUMENTS

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EXAMINER INITIAL	OTHER ART – NON PATENT LITERATURE DOCUMENTS (Include name of author, title of the article (when appropriate), till of the item (book, magazine, journal, serial, symposium, catalog, etc.), date page(s), volume-issue number(s), publisher, city and/or country where published.				
/E.D./	A1	Li, Jing, "The Cyranose Chemical Vapor Analyzer," Sensors, August, 2000 (also appears to have been available at <a href="http://www.sensorsmag.com/articles/0800/56/main.shtml">http://www.sensorsmag.com/articles/0800/56/main.shtml</a> as of June 21, 2005), nine pages			
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EXAMINER	/Elias Desta/	DATE CONSIDERED	02/27/2009	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.